

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. TAI, et al.

Serial No.: 10/784,996

Filed: FEBRUARY 25, 2004

Title: PROCESS FOR PREPARING PHOSPHOR PATTERN FOR
FIELD EMISSION DISPLAY PANEL, PHOTOSENSITIVE
ELEMENT FOR FIELD EMISSION DISPLAY PANEL,
PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY
PANEL AND FIELD EMISSION DISPLAY PANEL

Group AU: 1756

Examiner: John A. McPherson

Confirm. No.: 9776

RESPONSE**Mail Stop: AMEND – FEE**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

December 5, 2005

SIR:

In response to the Office Action mailed June 28, 2005, the period for response having been extended for three (3) months by the attached Petition for Extension of Time, Applicants respectfully submit the enclosed Terminal Disclaimer and enclosed Translation of Japanese Patent Application No. 132254/1997 (Priority Application), with Declaration of accuracy of the translation, and, additionally, the following Remarks, for obviating claim rejections in this Office Action mailed June 28, 2005.

Initially, the obviousness-type double patenting rejection, over claims 1 and 2 of U.S Patent No. 6,416,931, set forth in Item 1 on pages 2 and 3 of the Office Action mailed June 28, 2005, is noted. The Examiner has indicated that this obviousness-type double patenting rejection can be overcome with a timely filed Terminal Disclaimer. In light thereof, enclosed please find a Terminal Disclaimer for the